



GP/2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fang Docket No.: 01-P-14755 US
Serial No.: 09/941,963 Art Unit: 2823
Filed: 8/28/2001 Examiner: Hsien-Ming Lee
For: Method of Cleaning an Inter-Level Dielectric Interconnect

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Exhibits A – D (14 pages)
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Respectfully submitted,

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